

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/437,135

Filed: November 10, 1999

For: SEMICONDUCTOR DEVICE AND METHOD  
FOR FORMING THE SAME

)

) Group Art Unit: 2813

) Examiner: Erik J. Kielin

) Confirmation No. 7576

) Date: January 6, 2004

**RESPONSE TO SPECIES ELECTION REQUIREMENT**

Mail Stop - Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

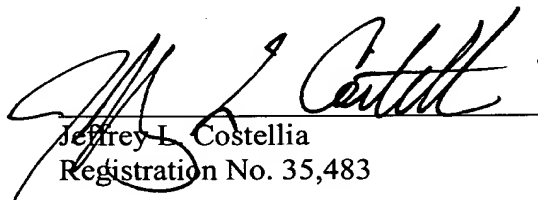
In response to the Restriction Requirement/Election of Species dated  
December 10, 2003 applicants respond as follows.

**REMARKS**

In response to the Office Action of December 10, 2003, Applicants hereby elect  
Group II, forming TFTs using two laser annealing steps and readable on claims 1-14 and 29.

Consideration and allowance of the instant application are now respectfully requested.

Respectfully submitted,

  
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